

Docket No.: 1794-0179PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Michio WATANABE et al.

Application No.: 10/567,250

Confirmation No.: 3050

Filed: January 5, 2007

Art Unit: 2891

For: METHOD OF MANUFACTURING MICRO  
TUNNEL-JUNCTION CIRCUIT AND MICRO  
TUNNEL-JUNCTION CIRCUIT

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Examiner: J. Doyle

**REPLY TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Madam:

In reply to the Restriction Requirement dated July 2, 2009, the following remarks are respectfully submitted in connection with the above-identified application.

**This reply includes:**

**Remarks**